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Logic-memory device of a mechanical resonator
Atsushi Yao and Takashi Hikihara

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Mechanical mixing in nonlinear nanomechanical resonators
Logic-memory device of a mechanical resonator

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We report multifunctional operation based on the nonlinear dynamics in a single microelectromechanical system (MEMS) resonator. This letter focuses on a logic-memory device that uses a closed loop control and a nonlinear MEMS resonator in which multiple states coexist. To obtain both logic and memory operations in a MEMS resonator, we examine the nonlinear dynamics with and without control input. Based on both experiments and numerical simulations, we develop a device that combines an OR gate and memory functions in a single MEMS resonator.

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Microelectromechanical systems or nanoelectromechanical systems (MEMS or NEMS) resonators have been developed for use as filters, frequency references, and sensor elements. Recently, significant research has focused on mechanical computation based on MEMS or NEMS resonators. Some studies have shown that a single mechanical resonator can be used as a mechanical 1-bit memory or as mechanical logic gates. Recently, multifunctional operation has been demonstrated in the form of a shift-register and a controlled NOT gate made from a single mechanical resonator. The next phase is to use a closed loop control to generate multifunction devices, which consist of memory and multiple-input gates, in a single device. The closed loop allows output and excitation signals to be fixed at a single frequency. The goal of the work presented in this letter is to develop multifunction operation from a nonlinear MEMS resonator in which multiple states coexist with closed loop control.

Nonlinear dynamical responses are commonly observed in a microelectromechanical or nanoelectromechanical resonator. The nonlinear dynamics of the resonator is well known to be described by the Duffing equation. Such a nonlinear resonator has hysteretic characteristics, which lead to two stable states and one unstable state, depending on the frequency or excitation force.

This letter focuses on fabricating a multifunction device that offers logic and memory (called a “logic-memory device”). To do this, we examine the nonlinear dynamics in a MEMS resonator with and without control input. In the following, we discuss the experiments and numerical simulations that allowed us to develop a device that combines multiple-input gate and memory functions in a single nonlinear MEMS resonator.

The proposed comb-drive MEMS resonator is shown in Fig. 1. The resonator consists of a perforated mass with a width, length, and thickness of 175, 575, and 25 μm, respectively. When the comb-drive resonator is electrically excited, the mass vibrates in the lateral direction. The vibration of the mass is detected by using a differential measurement in vacuum (around 10 Pa) at room temperature. The output voltage of the differential measurement is $V_{\text{out}} = 7.2 \text{ V sm}^{-1} \times f_e V_{\text{ace}} A_e \sin(4\pi f_e t + \phi_e)$, where $A_e$ denotes the displacement amplitude, $\phi_e$ is the phase, $f_e$ is the excitation frequency, and $V_{\text{ace}} (= 0.6 \text{ V})$ is the ac excitation amplitude. The vibration displacement is measured without additional sensors; therefore, the MEMS resonator is equipped with a comb drive that normally serves as a forcing actuator, but which simultaneously serves as a displacement sensor.

Figure 2(a) shows the amplitude frequency response (without control input $u_c$). The MEMS resonator produces a hysteretic response: the curves differ for increasing and decreasing frequency sweeps. The nonlinear dynamics of the MEMS resonator is qualitatively modeled as follows:

$$\frac{d^2 x}{dt^2} + \frac{2\pi f_0}{Q} \frac{dx}{dt} + \left( \frac{2\pi f_0}{Q} \right)^2 x + 2\lambda x^3 = 4.0 \text{ m} (\text{Vs})^{-1} \times (V_{\text{dc}} + u_c) \sin 2\pi f_0 t, \quad (1)$$

![Fig. 1. Schematic of MEMS resonator, measurement system, and control system that relates to logic inputs.](image-url)
where $x$ denotes the displacement, $f_n$ is the excitation frequency, $f_0 (= 8.6644 \text{ kHz})$ is the resonance frequency, $Q (= 25 000)$ is the quality factor, $x = 7.06 \times 10^{16} \text{ (sm)}^{-2}$ is the nonlinear mechanical spring constant, $V_{dcn}$ is the dc bias voltage, and $L_n$ is the control input. The parameters are obtained based on our reported parameter estimation method. Fig. 2(b) shows the amplitude as a function of excitation frequency for the resonator as determined by numerical simulations at $V_{dcn} = 150 \text{ mV}$ and $u_e = 0.0 \text{ mV}$. At any given frequency in the hysteretic region, the MEMS resonator exhibits two coexisting stable states. In the following experiments and simulations, the excitation frequency is fixed at 8.6654 kHz.

Figure 3(a) shows the experimentally determined hysteretic behavior as a function of dc bias voltage $V_{dc}$ at $u_e = 0.0 \text{ mV}$. The corresponding numerical results are shown in Fig. 3(b) with respect to numerical dc bias voltage $V_{dcn}$. The hysteretic region exists at $95 \text{ mV} < V_{dc} < 275 \text{ mV}$ in Fig. 3(a) and $105 \text{ mV} < V_{dcn} < 245 \text{ mV}$ in Fig. 3(b). The difference of hysteretic regions is caused by noise in Fig. 2(a). The nonlinear MEMS resonator has stable regions (solid line) that are completely separated by an unstable region (dashed line). These stable regions, which correspond to large and small amplitude vibrations, define two states of the single-output logic or memory device in a single MEMS resonator. In the numerical simulations and experiments, a displacement amplitude greater than 3.0 $\mu$m is regarded as a logical “1”; a value less than 3.0 $\mu$m is regarded as a logical “0” for logic and memory output. Hereinafter, the numerical and experimental dc bias voltages ($V_{dcn}$ and $V_{dc}$) are fixed at 150 mV.

We now discuss the nonlinear dynamics with control input as a logic operation. Fig. 1 shows the control system to perform the logic operation. The switching between two coexisting stable states was done by a displacement feedback control in the nonlinear MEMS resonator. Based on the results, the feedback control is performed. The logic inputs are applied to the MEMS resonator in the form of two dc voltages ($L_{in1}$ and $L_{in2}$). In the experiments, the control input $u_e$ is described as follows:

$$u_e = L_{in1} + L_{in2} - K_e V_{ave}^2,$$

where $K_e$ denotes the feedback gain and $V_{ave}^2$ is a slowly changing dc voltage that depends on the displacement.

The corresponding numerical control input $u_n$ is described as follows:

$$u_n = L_{inn1} + L_{inn2} - K_n A_{ave}^2,$$

$$A_{ave}^2 = \frac{A_{n1}^2 + A_{n2}^2 + \cdots + A_{nm}^2}{M},$$

where $L_{inn1}$ and $L_{inn2}$ denote the input signals that are the logic inputs, $K_n$ is the feedback gain, and $M$ is a natural number.
around each solution. The convergence conditions depend on the two basins of attraction.\textsuperscript{8,12} The light region (displacement amplitude greater than 3.0 \textmu m) in Fig. 4 is set to 150.0 mV (37.5 mV), the logic input is regarded as logical 1 (logical 0). The logic inputs (0, 0) of input signals ($L_{inn1}$, $L_{inn2}$) have a value of 75.0 mV, (0, 1) and (1, 0) have a value of 187.5 mV, and finally (1, 1) have 300.0 mV, as shown by the light (aqua) circles in Figs. 4 and 5. The output of the device is a logical “0,” when the logic inputs are (0, 0), which correspond to a value of 75.0 mV. However, when the logic inputs are set to (0, 1), (1, 0), or (1, 1), the output corresponds to a logical “1.” Therefore, the single MEMS resonator combines the function of an OR gate and memory.

These logic and memory operations can be demonstrated experimentally in a single MEMS resonator. The operations are confirmed for the behavior of device at clock evolution. The calculated time evolutions of the device are shown in Fig. 6(a) and the corresponding experimental time evolutions are shown in Fig. 6(b). The calculated results are consistent with the experimental results. When electrical noise and surges appear in Fig. 6(b), no logic faults occur and the memory operations are not perturbed. The experimental modulation of the amplitude and the convergence conditions will be examined in more detail in a future presentation. When the excitation frequency changes, it is anticipated that desired operations of OR gate and memory cannot be achieved. Nevertheless, this work demonstrates both experimentally and numerically a combined device of OR gate and memory functions in a single MEMS resonator.

Here, we estimate an instantaneous power of the MEMS resonator. In Fig. 1, when the voltages of right electrode are excited by $v_1 = V_{dce} + v_{ace} \sin 2\pi ft$ and the left by 

$$v_2 = V_{dce} - v_{ace} \sin 2\pi ft,$$

the right and left comb capacitances ($C_1$ and $C_2$) are given by $C_1 = 5.75 \times 10^{-9}$ Fm$^{-1} \times (l + A_e \sin (2\pi ft + \phi))$ and $C_2 = 5.75 \times 10^{-9}$ Fm$^{-1} \times (l - A_e \sin (2\pi ft + \phi))$, where $A_e$ denotes the displacement amplitude and $l (= 100 \mu m)$ is the initial overlap between the fingers.\textsuperscript{11} The power of the MEMS resonator $p$ is described by 

$$p = v_1 \partial (C_1v_1)/\partial t + v_2 \partial (C_2v_2)/\partial t.$$

In this study, $l v_{ace}^2$ is much greater than $A_e V_{dce} v_{ace}$. Thus, the power is estimated as $1.13 \times 10^{-8}$ sin $4\pi ft$ W.

In conclusion, we numerically and experimentally demonstrated a multifunctional device consisting of a nonlinear MEMS resonator. We confirmed that when a control input is applied to a nonlinear MEMS resonator, two equal-amplitude regions exist because of the adjustment of the feedback input. Therefore, a single MEMS resonator can work as an OR gate. We also used numerical simulations to show that in the absence of the control input, the nonlinear MEMS resonator maintains its original logical state. Thus, this resonator also serves as a memory device. Therefore, we demonstrate a
combination of an OR gate and a memory device in a single MEMS resonator. Mahboob et al. have developed a device that combines a controlled NOT gate and memory functions in a single resonator at 2 K.17 In this letter, we realize a logic-mem-ory device of high reliability operating at room temperature with the logic inputs given as two dc voltages that do not depend on the phase. By considering the closed loop and bias inputs, these results open the way to further research in high and multi functionality in single and coupled resonators, which may take the form of multiple-input gates such as three- or four-input logic gates and memory.

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FIG. 6. Time evolution of the combined device (OR gate and memory). The initial memory output is a logical “1.” When the clock signal is high (low), the control input is (is not) applied to the MEMS resonator. Note that the nonlinear MEMS resonator is used as a logic (memory) device at high (low) clock signal. The logic inputs start from (0, 0) and continue to (0, 1), (1, 0), and (1, 1). The logic output in a MEMS resonator changes to logical “0,” “1,” “1,” and “1” at each high clock signal: (a) Numerical results. (b) Experimental results. In our experiments, the logic input 1 (0) of experimental input signal ($L_{\text{out}}$ or $L_{\text{in}}$) has a voltage of 150.0 mV (37.5 mV).

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